Two-Dimensional Materials Based Sensors

Guest Editors:

Dr. He Tian
tianhe88@tsinghua.edu.cn

Prof. Dr. Jian-Bin Xu
jbxu@ee.cuhk.edu.hk

Prof. Philip Feng
philip.feng@case.edu

Prof. Dr. Yang Xu
yangxu-isee@zju.edu.cn

Deadline for manuscript submissions:
31 March 2019

Message from the Guest Editors

Two-dimensional materials can be the building blocks for various type of sensors, such as photodectors, strain/pressure sensors, gas sensors et. The two-dimensional-based sensors can be also enlarged by creating two-dimentional heterostructures. The two-dimentional heterostructures can be produced by combining 2D-2D, 2D-3D, 2D-1D, 2D-0D structures. This special Issue aims to introduce the two-dimensional materials with the combination of nano-fabrications. Topics in general include, but are not limited, to:

- Two-dimensional materials/heterostructures-based sensors: 2D material growth, transfer, fabrication, device prototype and demo
- Two-dimensional materials/heterostructures as photodectors
- Graphene or other 2D materials-based strain/pressure sensor with high sensitivity
- Two-dimensional materials as bio-sensors
- Two-dimensional materials for acoustic or thermal sensing applications
Message from the Editorial Board

Sensors is a leading journal devoted to fast publication of the latest achievements of technological developments and scientific research in the huge area of physical, chemical and biochemical sensors, including remote sensing and sensor networks. Both experimental and theoretical papers are published, including all aspects of sensor design, technology, proof of concept and application. Sensors organizes Special Issues devoted to specific sensing areas and applications each year.

Author Benefits

Open Access: free for readers, with article processing charges (APC) paid by authors or their institutions.

High visibility: indexed by the Science Citation Index Expanded (Web of Science), MEDLINE (PubMed), Ei Compendex, Inspec (IET) and Scopus.

CiteScore 2017 (Scopus): 3.23; ranked 9/116 in 'Physics and Astronomy: Instrumentation' and 100/644 in 'Electrical and Electronic Engineering.'